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TEM study of annealing effects on chemical and structural properties of solution-processed Zn(O,S) buffer layers in Cu(In,Ga)Se₂ solar cells

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- 1. Motivation
- 2. Experimental
- 3. Chemical properties of the as-grown & annealed Zn(O,S) buffers
- 4. Bandgap energies of the Zn(O,S) buffers before & after annealing
- 5. Crystal structure of the Zn(O,S) buffers and corresponding phase analyses
- 6. Conclusions

Motivation

Zn(O,S)

- non-toxic
- wide & tunable bandgap (2.6 3.6 eV) [1]
- Cu(In,Ga)Se₂ (CIGS) solar cells with solution-processed Zn(O,S) show high conversion efficiency above 23% [2]
- earth abundant, low cost, ...
- promising buffer material to replace CdS

Post-growth annealing

influences achieved performance

Transmission electron microscopy

- characterize chemical & structural properties
 - → study influence of annealing on microchemistry & microstructure



[1] B.K. Meyer *et al.*, Appl. Phys. Lett. **85** (2004) 4929
[2] M. Nakamura *et al.*, IEEE J. Photovolt. **9** (2019) 1863



Experimental



Fabrication of solar cells

- CIGS: in-line multi-stage coevaporation
- Zn(O,S): chemical bath deposition (CBD), 20 nm
- (Zn,Mg)O: rf-sputtering
- ZnO:Al: dc-sputtering

Annealing

- performed in air on a hot plate, 30 min
- first @ 150°C, then @ 200°C

Characterization and phase analysis

- bandgap measurements: angle-resolved electroreflectance spectroscopy (ARER)
- chemical analysis: energy-dispersive X-ray spectroscopy combined with scanning transmission electron microscopy (STEM/EDXS)
- crystal structure: high-resolution transmission electron microscopy (HRTEM) and nanobeam electron diffraction (NBD)



Chemical properties of the Zn(O,S) buffers





- In as-grown Zn(O,S) buffer, only Zn, O & S present, more O than S; other elements are artifacts
- In annealed Zn(O,S) buffer, the Cu concentration significantly increases, while the Zn concentration decreases
 interdiffusion of Cu and Zn
- SSO* value increases after annealing

*SSO: [S]/([S]+[O])

Bandgap energies of the Zn(O,S) buffers





- Before annealing, one resonance at 2.89 eV is detected → bandgap energy of Zn(O,S) (2.6 3.6 eV)
- After annealing at 200°C for 30 min, bandgap of Zn(O,S) slightly changes (2.89 eV \rightarrow 2.85 eV)
- An additional resonance at 2.33 eV \rightarrow a secondary phase in the buffer \rightarrow CuS (2.36 eV), Cu₂Se (2.23 eV), or Cu₃Se₂ (2.37 eV)

J. Seeger et al., IEEE 46th PVSC, USA (2019) 0949

J. Seeger et al., Appl. Phys. Lett. 115 (2019) 263901

Bandgap energies of the Zn(O,S) buffers





- $E_{Zn(O,S)}(x) = x E_{ZnS} + (1-x)E_{ZnO} b(1-x)x$ [1]
- *E*_{Zn(O,S)}(*x*): bandgap of Zn(O,S)
- *E*_{ZnS}: bandgap of ZnS (3.6 eV)
- *E*_{ZnO}: bandgap of ZnO (3.2 eV)
- x: SSO value in Zn(O,S)
- b: a bowing parameter (~ 3.0 eV)



 Average calculated bandgap 2.86 eV from STEM/EDXS results and the measured bandgap 2.89 eV by ARER match each other
 reliability of STEM/EDXS and ARER measurements

[1] B.K. Meyer et al., Appl. Phys. Lett. 85 (2004) 4929

Crystal structure of the Zn(O,S) buffers



- $T = 200^{\circ}C$ as-grown Zn(O,S) Zn(O,S) CIGS CIGS 2 nm 2 nm [20
 - Nanocrystalline structure of the Zn(O,S) buffer layer, independent of the orientation of the underlying CIGS grains
 - Annealing @ 200°C does not significantly change the crystallinity of the buffer layer
 - Detailed analysis of chemical phases within Zn(O,S) buffer layers would be performed by NBD

Phase analyses of the Zn(O,S) buffers





- As-grown Zn(O,S) layer $E_{Zn(O,S)}(x) = 2.89 \text{ eV} \rightarrow \text{hexagonal } Zn(O_{0.28}S_{0.72}) \text{ or } Zn(O_{0.85}S_{0.15})$
- Annealed Zn(O,S) layer $E_{Zn(O,S)}(x) = 2.85 \text{ eV} \rightarrow \text{hexagonal } Zn(O_{0.30}S_{0.70}) \text{ or } Zn(O_{0.83}S_{0.17})$
- Lattice parameters of the possible Zn(O,S) phases can be determined accordingly, which can be used to identify the present phase

[1] B.K. Meyer *et al.*, Appl. Phys. Lett. **85** (2004) 4929

Phase analyses of the Zn(O,S) buffers (as-grown)



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- $Zn(O_{0.85}S_{0.15})$ with wurtzite structure (P6₃mc, a = b = 3.3 Å, c = 5.3 Å) fits the NBD pattern better than $Zn(O_{0.28}S_{0.72})$, in agreement with the STEM/EDXS results
- ZnS with wurtzite structure (P6₃mc, a = b = 3.8 Å, c = 6.3 Å) may be also present in the buffer, whose bandgap (3.6 eV) cannot be detected by ARER (maximum 3.5 eV)

Phase analyses of the Zn(O,S) buffers (T = 200°C)





Zn(O_{0.83}S_{0.17}) with wurtzite structure (P6₃mc, a = b = 3.3 Å, c = 5.4 Å) fits the NBD pattern better than Zn(O_{0.30}S_{0.70})
 Cubic Cu₂Se (Fm-3m, a = 5.7 Å) fits the NBD pattern of this region; hexagonal CuS (P6₃mc, a = b = 3.8 Å, c = 16.3 Å) exists in another region as shown by HRTEM imaging → coexistence of Cu₂Se & CuS

Conclusions

- Annealing at 200°C leads to Cu diffusion from CIGS into the solution-processed Zn(O,S) buffer layer, forming a secondary phase
- Cubic Cu₂Se and hexagonal CuS are the most likely Cucontaining secondary phases with a bandgap energy of ~2.3 eV
- Due to the limitations of ARER, HRTEM and NBD, other phases cannot be excluded
- Annealing at 200°C does not significantly change the crystallinity (nanocrystalline) of the Zn(O,S) buffer layer, and slightly changes the stoichiometry of Zn(O,S)

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